

NV-Core Inspection System

Unique Inspection System across Cohu Handlers



Automotive



Mobility



IoT/IoV & Optoelectronics



Computing & Network



Industrial & Medical



Consumer

NV-Core enables advanced inspection capabilities across Cohu's handler portfolio. NV-Core latest advance inspection technologies include innovative solutions such as 3D Flex for 3-dimensional topographic inspection, sidewall micro-crack detection, and infrared inspection for sub-surface defect detection. In addition to device quality inspection, by mastering the "all-in-one" solution, Cohu can offer unique capabilities for handler's diagnostics and alignments, that enable the highest productivity performance.

Key Features

- Top silicon shiny dies micro-crack detection down to 2 μm
- Micro-scale sidewall defect inspection down to 5 μm
- Inner cracks detection on silicon devices
- Wafer vision mapping and skeleton check
- Color camera inspection

Capabilities

- 2D and 3D lead/pad/ball/pin inspections
- Marking (OCV/OCR), presence and orientation inspections
- LED lens dome inspection (shape, scratches, bubbles...)
- Top/bottom/side crack detection
- Traceability (bar and matrix codes)
- Advanced surface inspection and post sealing quality inspection

- Micro-crack Detection
 - Visible HR sidewall solution
 - Infrared sidewall, backside & intape solution
- 3D Flex® for True Ball/Bump co-planarity
- Dedicated micro-crack Algorithm
- ViewMap and Wafer Quality Map

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3D Flex® Vision System

3-dimensional measurement equipment into the volume production environment for wafer level chip scale package (WLCSP) Inspection.

Based on Moiré interferometry, the 3D Flex Vision system combines a sequence of touchless 2-dimensional images with projected light patterns to generate high accuracy 3-dimensional measurement of inspected devices. A dedicated algorithm generates a topographic view of devices, accurately measuring ball or bump height, coplanarity, quality and body warpage, enabling high-speed inspection of WLCSPs with micrometer resolution.

- Ball/bump height and coplanarity
- Ball/bump 3D
- Horizontal mount under 1 turret position



ViewMap and Wafer Quality Map

Wafer input mapping supervision

- Wafer mapping and quality map merging
- Code reader
- Skeleton check



Aquillae HR Sidewall

Aquillae solution is designed to identify micro-cracks on an integrated circuit that often go undetected using only electrical test, ultimately minimizing end-product failures.

The Aquillae inspection module combines a high-resolution camera with dedicated image processing algorithms to offer a breakthrough solution for early detection of micro-cracks WLCSPs and bumped dies. Providing this level of inspection enables semiconductor manufacturers to ensure the highest level of product quality, which is imperative in high-end applications.

- Down to 5 μm defect size detection*
- Dedicated micro-crack algorithm
- 1 HR image per component side



Aquillae Infrared

Infrared imaging has the ability to see through silicon, inspecting the structure underneath the surface that is not otherwise observable with traditional vision inspection systems. Cohu's unique innovation offers a breakthrough by integrating infrared imaging for enhanced micro-crack and sub-surface detection on wafer level chip scale packages (WLCSPs) onto a high-speed automation platform that delivers an economical solution for high quality inspection.

- Down to 1 μm crack detectability with infrared inspection
- Inner micro-crack detection
- Ability to see through silicon, inspecting the structure underneath the surface



*Low over rejection

- Micro-crack Detection
 - Visible HR sidewall solution
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- 3D Flex® for True Ball/Bump co-planarity
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Specifications

3D Flex® Vision System

	Packages [mm]	FOV [mm]	Resolution [μm/px]	3S Repeatability [μm]	Min. Detectable Chipout, Void [μm/px]	Min. Detectable Scratch, Crack [μm/px]
3D	2 x 2 to 6.5 x 6.5	7 x 7	0.8	10	NA	NA
2D	2 x 2 to 6.5 x 6.5	7 x 7	14.5	8	45 x 45	45 x 90
UPH	Up to 30K					

Aquilae HR Sidewall

FOV	Standard Configuration			Option
Camera Resolution	5 MP			12 MP
Max Device Length size*	3 mm	8 mm	12 mm	12 mm
Min Detectable Crack size*	5 μm*	10 μm*	15 μm*	10 μm*
NY32W UPH w/o Dynamic Focus	16K	16K	16K	14K
NY20 UPH w/o Dynamic Focus	18K	18K	18K	15K

Aquilae Infrared

FOV	Standard Configuration
Camera Resolution	VGA
Max Device Length size*	6 mm
Min Detectable Crack size*	~1 μm*
NY32W UPH w/o Dynamic Focus	18K
NY20 UPH w/o Dynamic Focus	20K

*Note: Feasibility required to confirm min. detectable crack size
For detailed performance specifications, please contact Cohu.

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Aquila HR Sidewall

Aquila Infrared

FOV	Standard Configuration
Camera Resolution	VGA
Max Device Length size*	6 mm
Min Detectable Crack size*	~1 μm*
NY32W UPH w/o Dynamic Focus	18K
NY20 UPH w/o Dynamic Focus	20K

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